



Cite this: *CrystEngComm*, 2025, 27, 5848

Morphological control of a metal–organic framework for single-crystal electronic device fabrication

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Single-crystal electronic devices of metal–organic frameworks (MOFs) unveil their intrinsic electrical conductivities by eliminating the influence of grain boundaries. Their fabrication demands sophisticated control of crystal morphology: micro/nano fabrication requires crystals with sub-micrometer thicknesses, whereas manual fabrication requires those with hundred-micrometer lengths. Herein, we report morphological control of an electrically conductive MOF, $\text{Zn}_2(\text{TTFTB})$ (TTFTB^{4-} = tetrathiafulvalene tetrabenzoate), by synthetically tuning nucleation and growth processes during crystallization. Whereas adjusting water content, organic solvent, solution pH, metal ion concentration, and reaction procedures, including temperature, time, and heating and cooling rates, did not produce crystals for either device fabrication method, increasing the concentration of H_4TTFTB led to crystals exhibiting an average length of 450 μm , with the longest above 800 μm . The growth of large $\text{Zn}_2(\text{TTFTB})$ crystals is facilitated by self-assembly of the ligand in the reaction mixture before formation of the MOF. These large crystals enabled manual fabrication of single-crystal 2-contact probe devices, displaying an average electrical conductivity of $3.84 \times 10^{-6} \text{ S cm}^{-1}$ under ambient conditions.

Received 23rd May 2025,
Accepted 31st July 2025

DOI: 10.1039/d5ce00534e

rsc.li/crystengcomm

Introduction

Electrically conductive metal–organic frameworks (MOFs) combine efficient charge transport with microporosity and high surface area,^{1–5} empowering applications of MOFs in supercapacitors, electrocatalysis, chemiresistive sensors, and thermoelectrics.^{6–9} A key metric of this class of materials is electrical conductivity, which is typically measured *via* electrical characterization of a pressed-pellet or single-crystal electronic device.^{10–12} Pressed-pellet electrical characterization is more commonly employed because it is independent of material size and morphology, yet it has several drawbacks. This method is incapable of measuring the intrinsic electrical conductivity because exerting a high pressure on a MOF might cause structural damage¹⁰ and grain boundaries between crystallites may dominate the electrical conduction.¹³ In addition, it cannot assess the anisotropy of electrical conductivity, which can vary significantly due to structural

variations across different crystal orientations, preventing a thorough investigation of charge transport pathways.¹⁰ In contrast, the single-crystal electrical characterization can reveal the intrinsic and anisotropic electrical conductivity in a MOF, enabling accurate evaluation of this critical property and in-depth investigation of charge transport mechanisms.¹³

Single-crystal electronic devices with MOFs can be produced by either micro/nano fabrication or manual fabrication. The former applies lithography and deposition technologies to place electrodes onto a crystal precisely. It typically requires crystals with a thickness below 300 nm and lateral sizes of above 1 μm due to instrumentation limitations.^{13–15} This method imposes high demands on both instrumentation and crystal quality, where the latter includes mechanical robustness, thermal stability, and chemical stability across a range of solvents and developing agents. The manual fabrication method comprises manual attachment of conductive wires onto a crystal *via* conductive paste, which typically demands the length of the crystal to be above 200 μm .^{10,16} Accordingly, it imposes requirements on growing long crystals that would facilitate device fabrication under conventional optical microscopes.^{10,17} Moreover, large crystals enable structural determination by single-crystal X-ray diffraction (SC-XRD) at various temperatures¹⁸ and pressures,¹⁹ which might reveal details of phase changes that typically cause variations in electrical conductivity.²⁰ Overall, the single-crystal electronic device

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fabrication of MOFs requires sophisticated morphological control of their crystals.

Herein, we report strategies to tune crystal morphologies as a preliminary example of electrically conductive MOFs, $\text{Zn}_2(\text{TTFTB})$ (H_4TTFTB = tetrathiafulvalene tetrabenzoic acid).²¹ In this material, redox-active TTF moieties form 1D columns through π - π stacking, and some of them are oxidized to introduce radical cations as holes.¹⁶ Previous synthesis of $\text{Zn}_2(\text{TTFTB})$ yielded rod-like crystals whose length was consistently shorter than 200 μm , yet whose thickness was well above 1 μm .^{16,21} Accordingly, single-crystal electronic devices can be challenging to achieve by either micro/nano or manual fabrications; instead, they are fabricated by attaching metallic probes to the crystal by manipulators of a probe station, which demands sophisticated equipment and does not allow electrical characterization under vacuum or at low temperature due to the fragility of the devices.

In this work, aiming at robust single-crystal electronic device fabrication for $\text{Zn}_2(\text{TTFTB})$, we explored synthetic strategies to either reduce the cross-sectional width or improve the length of crystals. Specifically, we modulated nucleation and crystal growth rates by adjusting reaction time, temperature, heating and cooling rates, solvent, and reactant concentrations. Whereas trials towards nanowires or thin films of $\text{Zn}_2(\text{TTFTB})$ were not successful, increasing the ligand concentration led to the growth of large crystals whose average length reaches nearly 450 μm , with the longest one exceeding 800 μm . This success was rationalized by pre-assembly of H_4TTFTB into π -stacked columns under a high ligand concentration before reacting with Zn^{2+} . The large crystals of $\text{Zn}_2(\text{TTFTB})$ enabled manual fabrication of single-crystal electronic devices, revealing an electrical conductivity ($\sigma = 3.84 \times 10^{-6} \text{ S cm}^{-1}$) that was consistent with previously reported values in ambient conditions.¹⁶

Results and discussions

First of all, we reproduced the literature procedure to synthesize $\text{Zn}_2(\text{TTFTB})$.²¹ Specifically, we mixed a solution of H_4TTFTB in 3 : 1 DMF/EtOH (DMF = *N,N*-dimethylformamide; EtOH = ethanol) with a solution of $\text{Zn}(\text{NO}_3)_2 \cdot 6\text{H}_2\text{O}$ in 1 : 1 EtOH/ H_2O , where the metal-to-ligand stoichiometric ratio was 3.7 : 1. The reaction mixture was maintained at 65 $^\circ\text{C}$ for 3 days with heating and cooling rates of 5 $^\circ\text{C}$ per hour. This procedure afforded dark red crystals (**Zn-1**) showing a consistent powder X-ray diffraction (PXRD) pattern with simulation from the reported crystal structure (Fig. S1a). **Zn-1** forms hexagonal-rod-like crystals with hexagonal pyramids covering both ends of the long axis (Fig. 1a and S2), which aligns with the crystallographic *c* axis.¹⁰ The longitudinal length ranges from several to tens of micrometers, and the cross-sectional width is above one micrometers. Both exhibit wide distributions with average values being 21 μm and 10 μm , respectively (Fig. 1d and S3a, Table S1). The length-to-width ratio is 2.1. Notably, these crystals are significantly

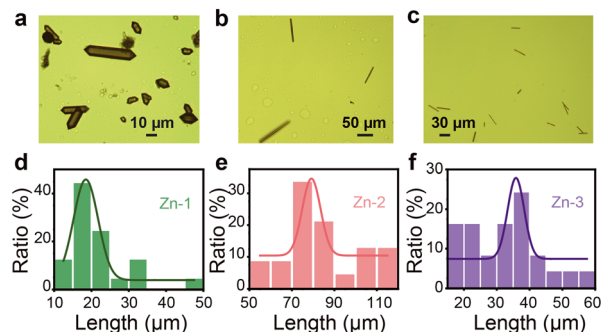


Fig. 1 Optical micrographs and length distributions of single crystals of (a and d) **Zn-1**, (b and e) **Zn-2**, and (c and f) **Zn-3**. Lengths were measured for 25 single crystals randomly selected from each sample.

smaller than those reported in the literature, possibly due to different degrees of ligand oxidation, solvent qualities, and synthetic conditions (*e.g.*, the reaction vessel, heating/cooling rate, and order of mixing of starting materials) that were unspecified in the reported procedure. Regardless, crystals of **Zn-1** do not meet the requirements for device fabrication: they are too thick for micro/nano fabrication and too short for manual fabrication.

Therefore, we aim to either reduce the thickness or increase the length of $\text{Zn}_2(\text{TTFTB})$ crystals by adjusting crystal growth conditions. The crystal formation typically includes a nucleation process and a successive growth process. The nucleation process begins in the liquid or solution phase and produces molecular aggregates, *i.e.*, nuclei.^{22,23} It is driven by supersaturation of the solution when the concentration of the starting material exceeds its solubility.²³ Subsequently, these aggregates may undergo growth, where they bind to surrounding starting materials, ultimately forming macroscopic crystals. This process should be reversible to facilitate self-healing of the crystal, reducing defects, disorders, and impurities. Typically, growing small crystals requires a rapid nucleation process, whereas growing large crystals demands a slow nucleation process, followed by a reversible growth process with sufficient starting materials. We modulated the crystal morphology of $\text{Zn}_2(\text{TTFTB})$ based on the above crystallization theory (Fig. 2). On the one hand, we aim to synthesize thin crystals to promote micro/nano fabrication by improving the nucleation rate. Trials include tuning water content (**Zn-2**), heating and cooling rates (**Zn-3**), reaction time (**Zn-4**), reaction temperature (**Zn-5**), organic solvent (**Zn-6**), and solution pH (**Zn-7**). Although the cross-sectional widths of crystals can be reduced to several

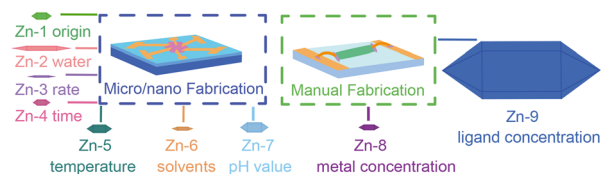


Fig. 2 Summary of trials for $\text{Zn}_2(\text{TTFTB})$ crystal growth. “Rate” stands for the heating and cooling rates.

micrometers in some trials, they remain too thick for micro/nano fabrication (Table S1).

On the other hand, we attempted to grow long crystals for manual fabrication by increasing the concentration of metal ions (**Zn-8**) or ligands (**Zn-9**). The latter produced large crystals whose average length was 450 μm , suitable for manual fabrication. The following discussion presents representative results of crystal growth from extensive experimental attempts.

Attempts to grow thin crystals for micro/nano fabrication

We first attempted to reduce the cross-sectional width of $\text{Zn}_2(\text{TTFTB})$ crystals below 300 nm to promote micro/nano fabrication. Water is known to modulate the crystal morphology of MOFs.^{24,25} It sometimes leads to the formation of nanowires or thin films.^{26,27} Regarding $\text{Zn}_2(\text{TTFTB})$, water might promote crystal growth along the crystallographic *c* axis by facilitating self-assembly of the hydrophobic TTF moieties, whereas it might inhibit growth within the crystallographic *ab* plane by compromising the coordination between Zn^{2+} and carboxylate groups. Thus, we tested the influence of water on the crystal morphology of $\text{Zn}_2(\text{TTFTB})$, yielding **Zn-2**. Given all other conditions intact, improving the water content from 25% as in the original reaction mixture to 45–56% increases the average length to 84 μm while reducing the average cross-sectional width to 5 μm (Fig. 1e and S3b). Accordingly, the length-to-width ratio increases to 16.8, yet the cross-sectional width remains too large for micro/nano fabrication. Further improving the water content deteriorates the crystal quality (Fig. S4).

To further reduce the cross-sectional width of the crystal, we attempted to improve heating and cooling rates that were expected to promote rapid nucleation and leave insufficient starting materials to grow large crystals.²⁸ Specifically, we enhanced the heating and cooling rates from 5 $^{\circ}\text{C}$ per hour to 100 $^{\circ}\text{C}$ per hour, while retaining other synthetic conditions of **Zn-2**. The product, **Zn-3**, displayed a comparable length-to-width ratio (16), yet its

average length and cross-sectional width declined to 32 μm and 2 μm , respectively (Fig. 1f and S3c). Attempts using crystals of **Zn-3** for micro/nano fabrication did not yield working devices due to crystal cracking and bad crystal-electrode contact (Fig. S5).

We further varied several other synthetic conditions, including reaction time, reaction temperature, organic solvent, and solution pH, to reduce the cross-sectional width of crystals. The reaction time determines the time spanned for self-healing of the crystal, thereby influencing the growth process. The reaction temperature affects reversibility and kinetics of coordination, and it also implicitly influences solvent properties. For instance, DMF tends to decompose to form dimethylamine at relatively high temperatures, which facilitates the deprotonation of H_4TTFTB . The organic solvent determines the solubility of metal ions and ligands, thereby affecting the nucleation process. Finally, the pH value of the reaction mixture affects the deprotonation of ligands and the reversibility of coordination. Driven by this analysis, we tried to reduce the reaction time to 24 hours (**Zn-4**), change the reaction temperature to 85 $^{\circ}\text{C}$ (**Zn-5**), add methanol and acetonitrile (**Zn-6**), and add acetic acid (**Zn-7**). These trials yielded crystals whose lengths and cross-sectional widths are comparable with those of **Zn-1** (Fig. 4); none of them are suitable for micro/nano fabrication of single-crystal electronic devices (Fig. 3, S6 and S7).

Attempts to grow long crystals for manual fabrication

The abovementioned experiments showed difficulties in growing thin crystals of $\text{Zn}_2(\text{TTFTB})$ for micro/nano fabrication. Thus, we turned to grow long crystals, aiming at manual fabrication of single-crystal electronic devices. As the tuning solvent and reaction procedure (time, temperature, heating, and cooling rates) did not produce crystals longer than 100 μm , we opted to optimize the concentrations of metal ions and ligands. Increasing the concentration of Zn^{2+} by ~ 10 times, while keeping other reaction conditions of **Zn-1** intact, generated crystals (**Zn-8**) whose average length and width are 14 μm and 4 μm , respectively (Fig. S8). Thus, **Zn-8** is smaller than **Zn-1** and is too short for manual fabrication.

Finally, we reduced the metal-to-ligand ratio to 1:5 by improving the concentration of H_4TTFTB , while retaining

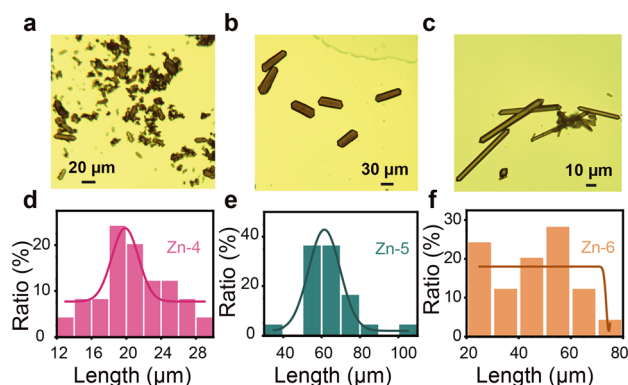


Fig. 3 Optical micrographs and length distributions of single crystals of (a and d) **Zn-4**, (b and e) **Zn-5**, and (c and f) **Zn-6**. Lengths were measured for 25 single crystals randomly selected from each sample.

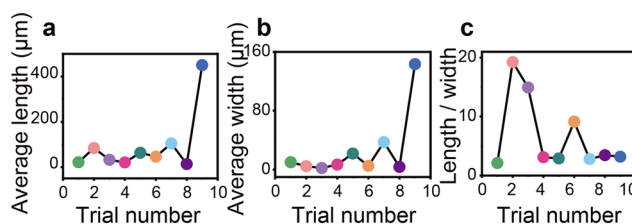


Fig. 4 (a) Average lengths, (b) widths, and (c) length-to-width ratios of **Zn-1** to **Zn-9** represented as dots from left to right. Data are averaged for 25 random selected single crystals from each sample.

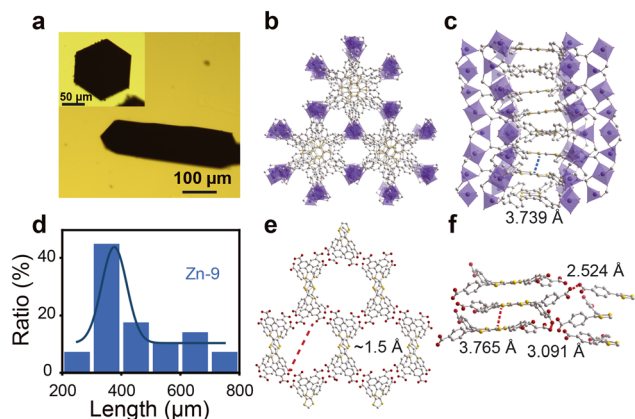


Fig. 5 (a) Optical micrographs of single crystals of **Zn-9** viewed perpendicular or parallel (inset) to the crystallographic *c* axis. (b and c) Portions of structures viewed parallel or perpendicular to the crystallographic *c*-axis of **Zn-9**, respectively. (d) Length distribution of single crystals of **Zn-9**. Lengths were measured for 25 single crystals randomly selected from the sample. (e and f) Portions of structures viewed parallel to the crystallographic *a* axis and *c* axis of **H₄TTFTB**. Grey, red, yellow, and purple spheres represent C, O, S, and Zn, respectively. Solvent and H atoms are omitted for clarity.

that of **Zn²⁺**. Applying the same procedure as that for **Zn-1** to this reaction mixture gave millimeter-long and thin crystals (Fig. S9b), as well as shorter and thicker hexagonal-rod-like crystals (Fig. 5a). The product showed a strong diffraction peak at $2\theta \approx 5^\circ$, which was not present in the simulated PXRD pattern of **Zn₂(TTFTB)** (Fig. S9). Washing it extensively with DMF and EtOH removed the first type of crystals and eliminated this additional diffraction peak. The remaining second type of crystals (**Zn-9**) exhibited average length and cross-sectional width of 450 and 143 μm, respectively (Fig. 5d and S10b). The longest crystal shows a length exceeding 800 μm. Owing to the large crystal size, we conducted SC-XRD characterization for **Zn-9**, which revealed a structure that is almost identical to the previously reported **Zn₂(TTFTB)**, except for the coordination spheres of **Zn²⁺** (Fig. 5b and c). The previously reported structure consists of 5-coordinated and 6-coordinated **Zn²⁺** ions alternating along the crystallographic *c* axis (Fig. S12d), whereas our newly solved structure replaces the 5-coordinated **Zn²⁺** ions with 4-coordinated ones (Fig. S12c). Regardless of slight differences in structural features, **Zn-9** crystals are large enough for manual fabrication of single-crystal electronic devices.

We further characterized the first type of crystals by SC-XRD and found a new crystalline phase of the **H₄TTFTB** ligand. The structure consists of 1D columns of **H₄TTFTB** in which the shortest intermolecular S⋯S and O⋯O distances are 3.765–3.860 Å and 3.091–3.158 Å, respectively (Fig. 5f and S9f). Thus, **H₄TTFTB** molecules are assembled *via* S⋯S interactions and weak hydrogen bonds. Notably, the former distance is comparable with the shortest S⋯S distance found in **Zn₂(TTFTB)** (3.739 Å) (Fig. 5c and S12e). These columns are connected *via* stronger hydrogen bonds with O⋯O distances ranging from 2.524 Å to 2.601 Å (Fig. 5f and S8f).

Together, they delineate a microporous structure with 1D hexagonal and cylindrical pores whose diameter was approximately 1.5 Å (Fig. 5e). The pores are filled with DMF, EtOH, and H₂O molecules.

The structure of **H₄TTFTB** and its co-existence with the MOF suggest a possible mechanism for the crystal growth of **Zn₂(TTFTB)** under a high ligand concentration.^{13,29} In the reaction mixture, **H₄TTFTB** molecules might dynamically self-assemble into the above structure through S⋯S and hydrogen bonding interactions. Then, the coordination of **Zn²⁺** to multiple ligands tweaks the structure of ligand assembly, which eventually leads to the formation of **Zn₂(TTFTB)**. In this process, the **H₄TTFTB** assembly inhibits deprotonation and reduces the concentration of free ligand molecules, together slowing down the nucleation process and facilitating the growth of large crystals. Such ligand-assembly-assisted crystal growth method has been applied for various MOFs,¹³ covalent organic frameworks,^{29–31} and halide perovskites.³² To verify this hypothesis, we conducted a synthetic trial where **H₄TTFTB** and **Zn²⁺** were added sequentially. The ligand was dissolved in a solvent mixture of DMF, water, and ethanol. It crystallized at room temperature within 24 hours (Fig. S13a and c). Adding **Zn²⁺** to this mixture and heating it at 85 °C generated **Zn₂(TTFTB)** crystals an average length of 334 μm (**Zn-10**; Fig. S13a, b and d), confirming the ligand-assembly-assisted crystal growth of **Zn₂(TTFTB)** under high ligand concentration.

Single-crystal electrical conductivity measurements

The large crystallite size of **Zn-9** enables the production of single-crystal electronic devices by the manual fabrication method. We selected 15 crystals of **Zn-9** and fabricated 2-contact probe devices by manually attaching gold wires onto the two ends of the long axis of the single crystal *via* conductive carbon pastes (Fig. 6a). Hence, the charge transport direction in the device aligns with the π -stacked TTF columns, *i.e.*, crystallographic *c* axis. These devices displayed Ohmic contact with linear current–voltage (*I*–*V*) curves (Fig. 6b). Their average direct-current (DC) electrical conductivity in ambient conditions (298 K, 38–45% relative humidity) is $3.84 \times 10^{-6} \text{ S cm}^{-1}$ (Fig. 6c), which is almost identical with the previously reported value acquired under similar conditions ($\sigma = 3.95 \times 10^{-6} \text{ S cm}^{-1}$).¹⁶ This value is

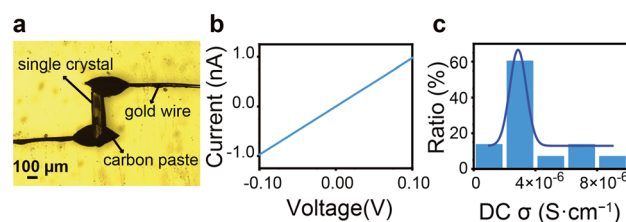


Fig. 6 (a) An optical micrograph of a two-contact probe single-crystal electronic device of **Zn-9**. (b) A representative *I*–*V* curve acquired at 298 K under humid air. (c) DC conductivity distribution of 15 devices.

an order of magnitude higher than the DC electrical conductivity observed for a pressed pellet of $\text{Zn}_2(\text{TTFTB})$ ($\sigma = 4.29 \times 10^{-7} \text{ S cm}^{-1}$) (Fig. S14), demonstrating the importance of single-crystal measurements in accurately revealing the intrinsic transport properties of the material. Interestingly, 10 crystals of H_4TTFTB exhibited comparable average single-crystal DC electrical conductivity ($\sigma = 3.08 \times 10^{-6} \text{ S cm}^{-1}$) (Fig. S15). This is consistent with the similar shortest intermolecular S...S distances in $\text{Zn}_2(\text{TTFTB})$ and H_4TTFTB , indicating charge transport through the π -stacked TTF columns. In addition, our previous studies on $\text{Cd}_2(\text{TTFTB})$, an analogue of $\text{Zn}_2(\text{TTFTB})$, showed peculiar atmospheric modulation of its DC electrical conductivity whose origin remains unclear.³³ The electrical conduction mechanism of $\text{Zn}_2(\text{TTFTB})$ is worth further investigation, which would benefit from the successful growth of large crystals herein.

Conclusions

In summary, we examined crystal growth conditions for a conductive MOF, $\text{Zn}_2(\text{TTFTB})$, aiming at synthesizing crystals suitable for fabricating single-crystal electronic devices. Tuning the water content, heating and cooling rates, reaction temperature, reaction time, solvent, and pH of the reaction mixture, as well as improving the concentration of Zn^{2+} , did not produce thin crystals for micro/nano fabrication nor long ones for manual fabrication. In contrast, enhancing the concentration of H_4TTFTB in the reaction mixture generated long crystals approaching 450 μm , which is likely facilitated by self-assembly of H_4TTFTB before the crystal growth. These long crystals can enable manual fabrication and electrical characterization of single-crystal electronic devices. Our work provides practical guidance regarding morphological control and size regulation of MOFs.

Experimental

Synthesis of Zn-9

$\text{Zn}(\text{NO}_3)_2 \cdot 6\text{H}_2\text{O}$ (13.8 mg, 66.5 μmol) was dissolved in a mixture of 0.35 mL of water and 0.35 mL of ethanol in a 4 mL scintillation vial. H_4TTFTB (43 mg, 89.5 μmol) was dissolved in a mixture of 0.525 mL of DMF and 0.175 mL of EtOH in a 4 mL scintillation vial. Both solutions were sonicated for 5 min. The former solution was slowly added to the latter with an automatic pipette. The reaction mixture was heated to 75 $^\circ\text{C}$ in 10 h in a programmable oven, kept at this temperature for 72 h, and cooled down to 30 $^\circ\text{C}$ in 10 h, affording millimeter-long and thin dark red crystals as well as shorter and thicker dark red crystals. The product was collected by vacuum filtration. It was rinsed with DMF eight times and then with EtOH eight times to remove the first type of crystals. The remaining second type of crystals is $\text{Zn}_2(\text{TTFTB})$ (**Zn-9**). Finally, the product was dried in a vacuum oven at 40 $^\circ\text{C}$ for 24 h.

Single-crystal X-ray diffraction (SC-XRD)

Crystals of $\text{Zn}_2(\text{TTFTB})$ (**Zn-9**) and H_4TTFTB were dispersed into a non-drying immersion oil (Cargille Laboratories). The former were vacuum-dried, whereas the latter were taken directly from the mother liquor. A single crystal suitable for X-ray diffraction was selected and mounted onto a goniometer. X-ray crystallographic analyses were performed on a Bruker D8 Venture diffractometer with PHOTON III detector in shutterless mode with an Excillum source (Liquid Ga $K\alpha$ radiation, $\lambda = 1.34138 \text{ \AA}$) equipped with an Oxford 1000 Plus liquid nitrogen vapor cooling device. Data for $\text{Zn}_2(\text{TTFTB})$ and H_4TTFTB were collected at 297 K and 100 K, respectively. The computing indexing, cell refinement, and data reduction on all molecules were processed using APEX5 software. Frame integration, including Lorentz-polarization corrections, and final cell-parameter calculations were processed with SAINT software. The data were corrected for absorption using the SADABS program based on symmetry-equivalent reflections combined with measurements at different azimuthal angles. Crystal structures were solved and refined against all F^2 values with the SHELXS, SHELXL, and APEX5 suite of programs.³⁴ All non-hydrogen atoms were refined with anisotropic displacement parameters. Hydrogen atoms were inserted in calculated positions and refined with a riding model. Disorder was modelled using standard crystallographic methods, including constraints, restraints, and rigid bodies where necessary. SC-XRD measurements revealed that the π - π stacking direction is along the long axis of crystals for both $\text{Zn}_2(\text{TTFTB})$ and H_4TTFTB .

Manual fabrication of single-crystal electronic devices

A single crystal with a smooth surface and regular shape was selected under an optical microscope (Guangzhou Liss Optical Instrument L3230) equipped with a digital camera (LIT Firefly 12). The crystal was then transferred onto a piece of glass slide, which was pre-patterned with two electrodes fabricated by depositing 4 nm Ti and 40 nm Au with an e-beam evaporator (ULVAC ei-5z) using a piece of Kapton tape as a shield mask. A gold wire was attached to one end of the rod-like crystal with carbon paste, and the other end of the gold wire was subsequently connected to the gold electrode with carbon paste. The same procedure was repeated on the other end of the crystal to fabricate a single-crystal two-contact probe device with electrical current transporting along the crystallographic c axis. The length and cross-sectional edge of the conduction channel were measured by the optical microscope and a digital camera.

DC I - V characterization

The device was placed in a mini electrical probe stage (INTEC HP1000G-PM). A probe was brought into contact with each gold electrode. Electrical characterization was conducted at room temperature (298 K) and in a humid air atmosphere with a relative humidity of 38–45%. DC I - V curves were acquired with a sourcemeter (Keithley 2636B). Voltage was scanned from

−0.1 V to 0.1 V with a step size of 1 mV, while the current was collected at each step. The DC resistance (R_{DC}) was extracted by linear fitting of the I - V curve according to Ohm's law. The electrical conductivity (σ_{DC}) was calculated by taking the geometry of the conduction channel into account:¹⁰

$$\sigma_{DC} = \frac{1}{R_{DC}} \times \frac{2\sqrt{3}L}{9a^2}$$

L is the length of the crystal, a is the cross-sectional width of the crystal, and the data can be measured from the optical microscope.

Author contributions

Y. W. conducted experiments. X. M. assisted with single-crystal X-ray crystallography. L. S. conceived the idea and oversaw the project. Y. W. and L. S. analyzed data, interpreted results, and co-wrote the manuscript.

Conflicts of interest

The authors declare no competing interests.

Data availability

Supplementary Information available: Experimental details, PXRD patterns, optical micrographs, SEM images, single-crystal structural information, I - V characteristics, crystal length, cross-section width, and electrical conductivity distributions. See DOI: <https://doi.org/10.1039/D5CE00534E>. The crystallographic information for $Zn_2(TTFTB)$ and H_4TTFTB have been deposited in the Cambridge Crystallographic Data Center (CCDC) under accession codes 2453173 and 2453174.^{35,36} They can be obtained from <https://www.ccdc.cam.ac.uk/structures/>.

Acknowledgements

This work is supported by the Zhejiang Provincial Natural Science Foundation of China (XHD23B0301) and the Research Center for Industries of the Future (RCIF Project No. WU2023C006) at Westlake University. We acknowledge the Instrumentation and Service Center for Molecular Sciences and the Instrumentation and Service Center for Physical Sciences at the Westlake University, as well as Westlake Center for Micro/Nano Fabrication, for the facility support and technical assistance. We thank Yunlong Fan and Prof. Jin-Hu Dou at Peking University for assistance with device fabrication. Y.W. thanks Yuan Cheng, Xin Li, Dr. Zhong Chen, and Xi Mu at Westlake University for assistance with characterization and data analysis.

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